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# Current Measurement and Associated Machine Protection in the ERL at BNL

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# Outline



## Introduction

ERL Purpose, layout, machine parameters

## Faraday Cup

Circuit Schematic

Commissioning waveforms

## Integrating Current Transformer

Description of device

Commissioning waveforms

## Timing

Bunch structures

## Machine Protection

## Pulse Counter

Block Diagram

## DCCT

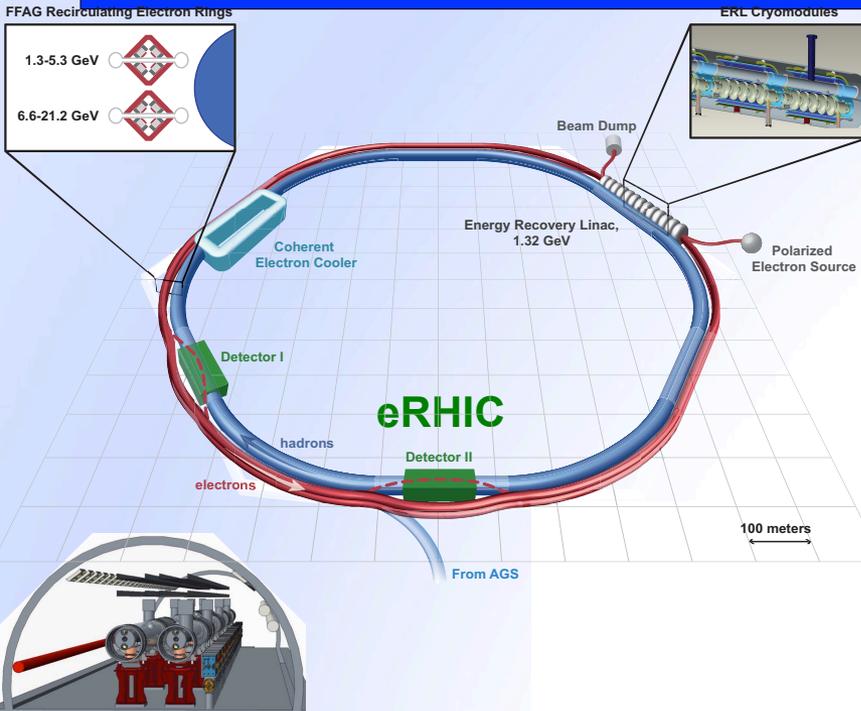
Description of device

Response times & curves

Bunch structures

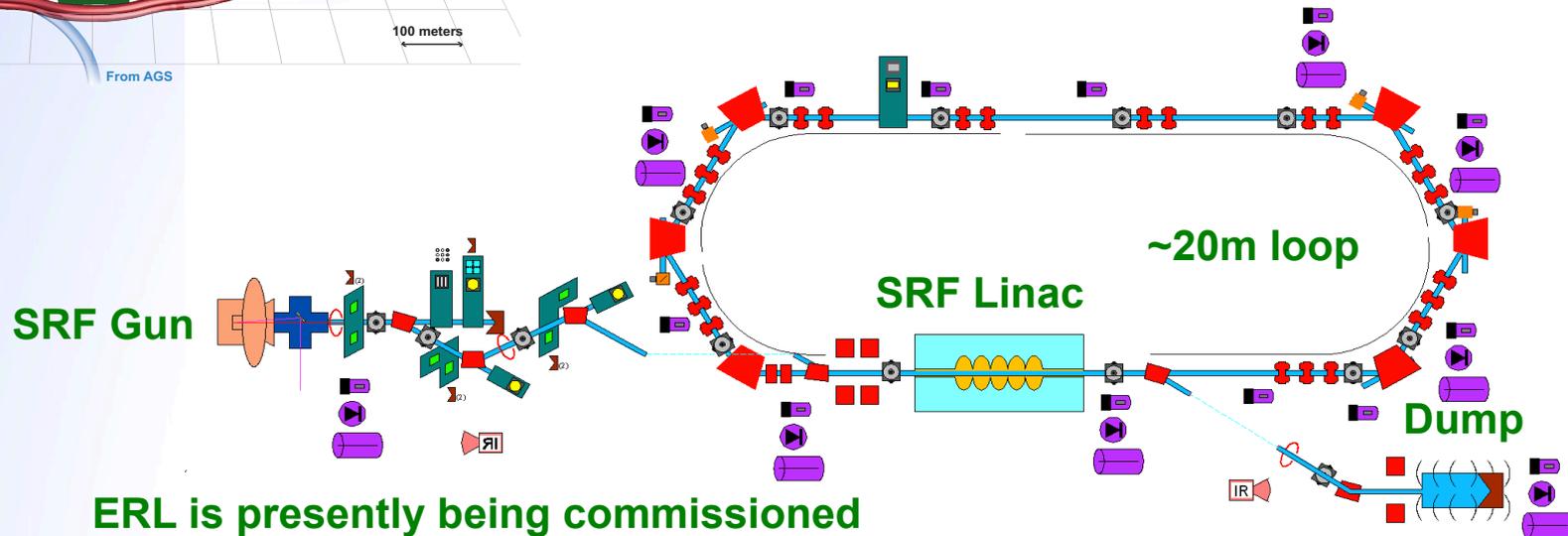
## Summary

# Introduction

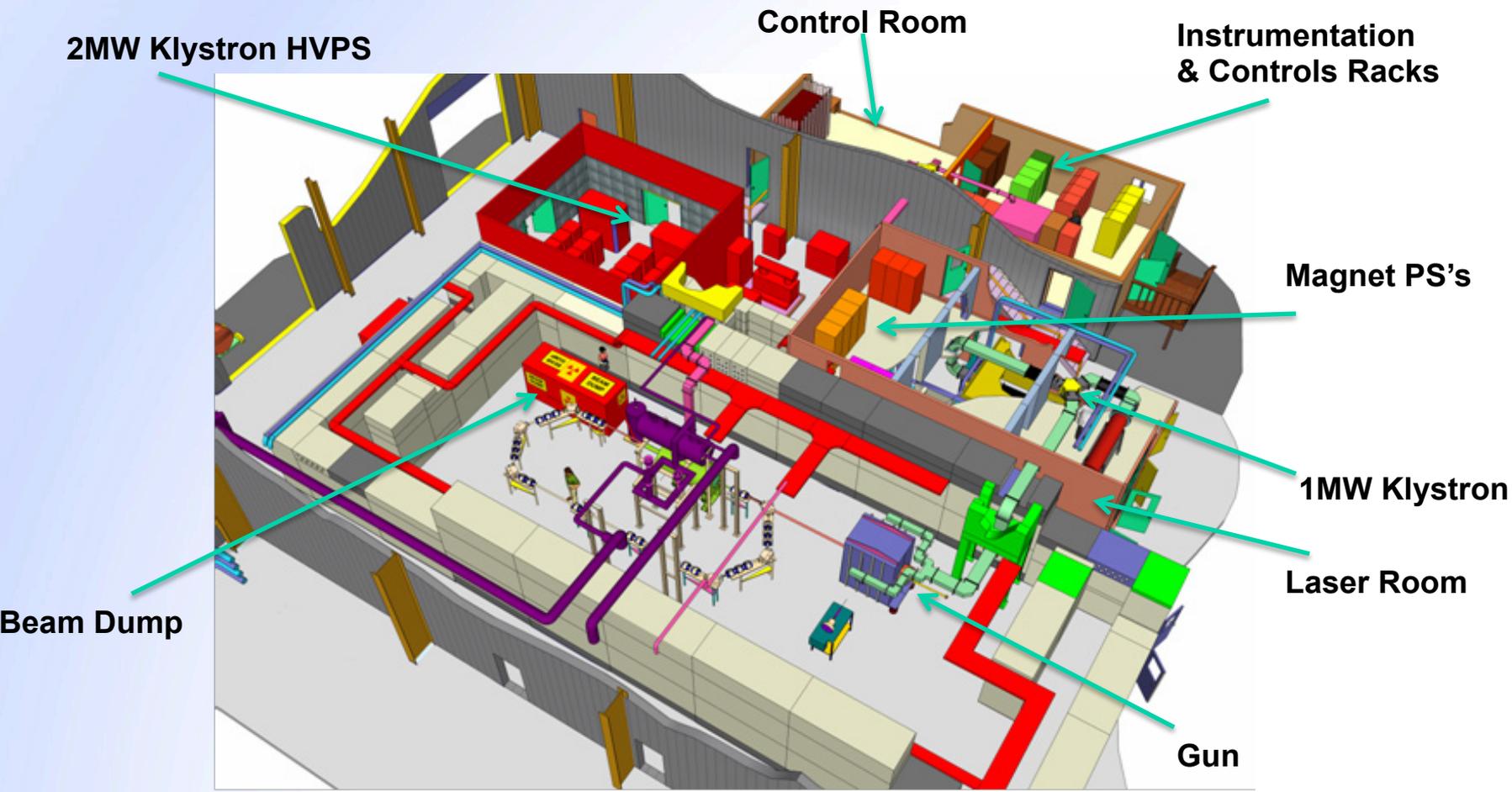


The R&D ERL facility serves a test bed for the Low Energy RHIC electron Cooling and eventually the electron-hadron collider, eRHIC (200GeV, 3.8km).

## ERL Instrumentation Layout



# ERL Facility Layout



# ERL Early Commissioning Parameters



Parameter	High Charge Mode	High Current Mode	Comments
Beam Energy (Injection)	~2.5 MeV		
Beam Current	50 mA	500 mA	
Bunch Charge	0.05 – 5 nC	0.7 nC	
Bunch Rep. Rate	9.38 MHz	704 MHz	
Bunch Length	30ps	20ps	
Car Rep. Rate	5kHz		Limited by integrator recovery time
Car Length	0 – 7 $\mu$ s (ICT) up to CW (DCCT)		
Train Rep. Rate	1 Hz		
Train Length	0 – 990 ms		

# ERL Instrumentation Requirements



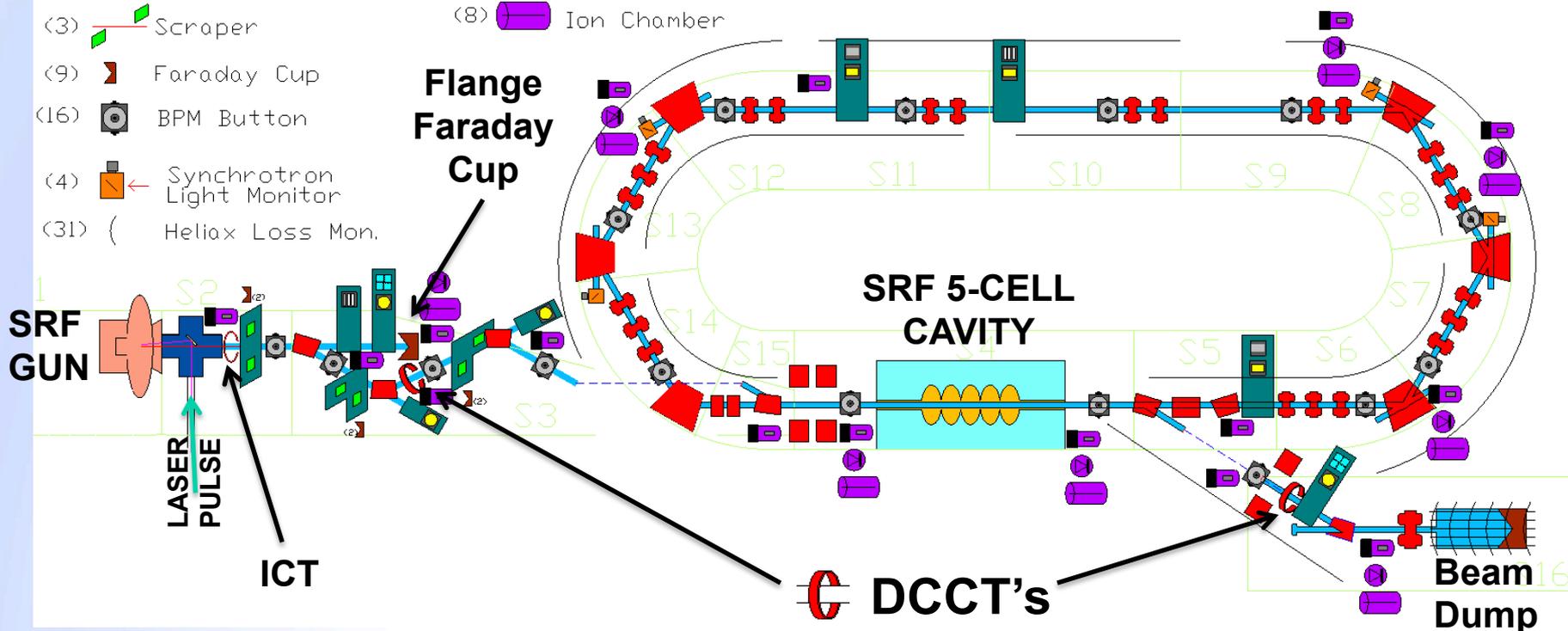
Parameter	Expected Value / Range	Accuracy	Resolution	Comments
<b>Current/Charge per bunch</b>				
<b>Current (Ops.)</b>	50 $\mu$ A – 500 mA	1%	0.1% at I=500 mA	Lower range needed for tuning.
<b>Bunch charge</b>	0.05 – 5 nC, 1 Hz – 10 MHz	5%	0.1% (at 5 nC)	1% will be sufficient for ERL.

- TWO instruments cover the Measurement Extremes:  
50 pA – 500 mA (1 bunch up to CW)
  - ICT: **50pA – 800 $\mu$ A** (1  $\times$  50pC – 50  $\times$  5nC / 200 $\mu$ s)
    - macrobunches < 7 $\mu$ s
  - DCCT: **50nA – 500mA** (1000  $\times$  50pC pulsed – Cw<sub>max</sub>)
    - macrobunches > 100 $\mu$ s long in pulsed mode
    - **Blind to macrobunches between 7 – 100 $\mu$ s !**
    - **Can't see beam in diag. beam line !**



# Instrumentation Layout

- |                                |                                      |            |
|--------------------------------|--------------------------------------|------------|
| (2)  DTR Screen                | (2)  Infrared Camera                 | Solenoid   |
| (3)  HE YAG Screen             | (2)  DC Current Transformer          | Quadrupole |
| (1)  Pepper Pot                | (1)  Integrating Current Transformer | Dipole     |
| (1)  Emittance Slit            | (16)  PMT                            |            |
| (2)  Flag Target Screen        | (8)  PIN Diode                       |            |
| (3)  LE YAG Screen             | (8)  Ion Chamber                     |            |
| (3)  Scraper                   |                                      |            |
| (9)  Faraday Cup               |                                      |            |
| (16)  BPM Button               |                                      |            |
| (4)  Synchrotron Light Monitor |                                      |            |
| (31)  Helix Loss Mon.          |                                      |            |



# Injection & Diagnostic Beam Line



– ICT (5:1 turns ratio,  $\sim 6\%/ \mu\text{s}$  droop) + BCM-IHR electronics (10kHz)

– BPM

– Scraper

– Emittance Slit

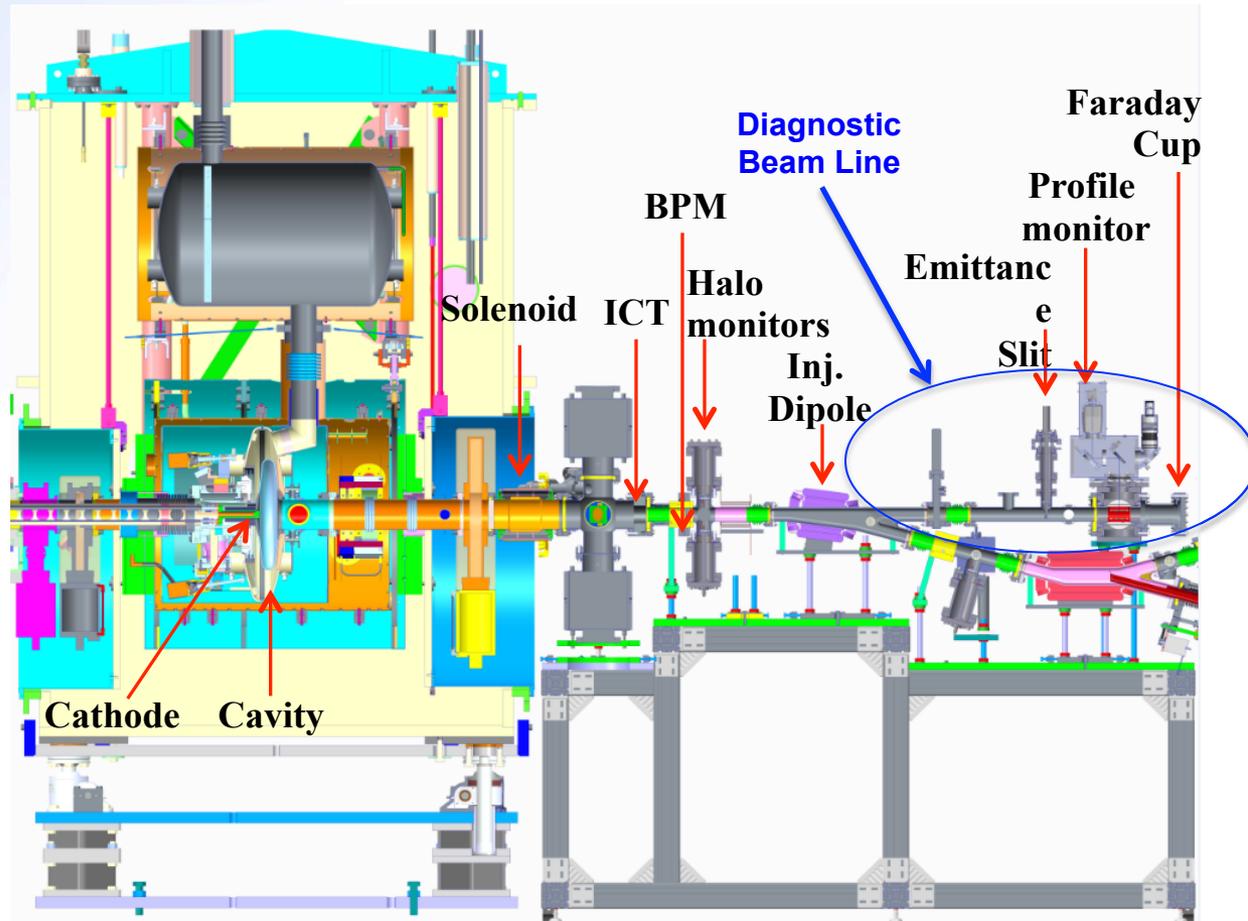
– Profile Monitor

– Faraday Cup

SS flange on  
ceramic break with  
copper mesh noise  
shield

– DCCTs (not pictured)

- Zig-Zag & Extraction



# Faraday Cup

- Faraday Flange

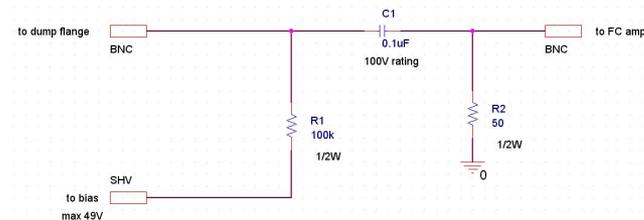


flange with enclosure to protect from exposure to faraday cup bias voltage

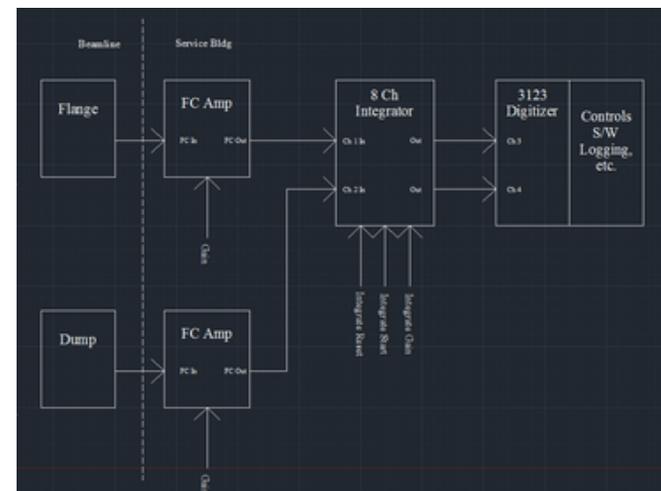


cap/resistor combo on Faraday cup/flange connection

1<sup>st</sup> beam tests made with O-Scope with direct connection...



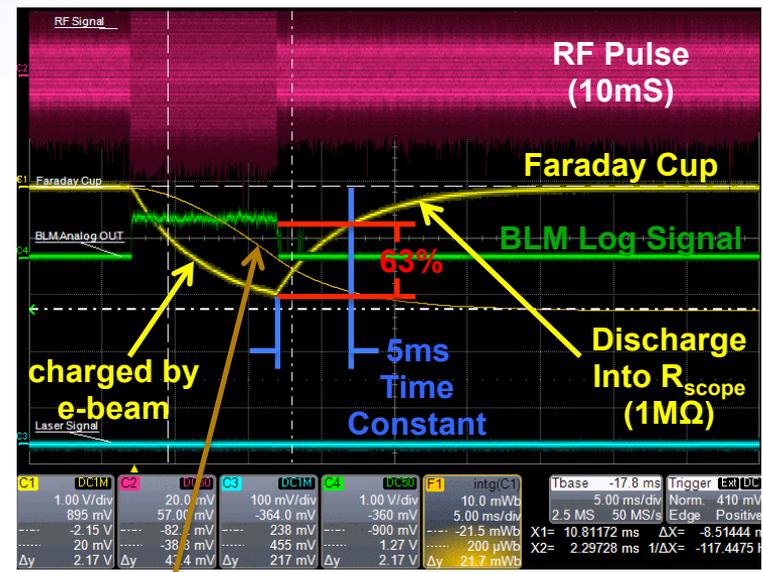
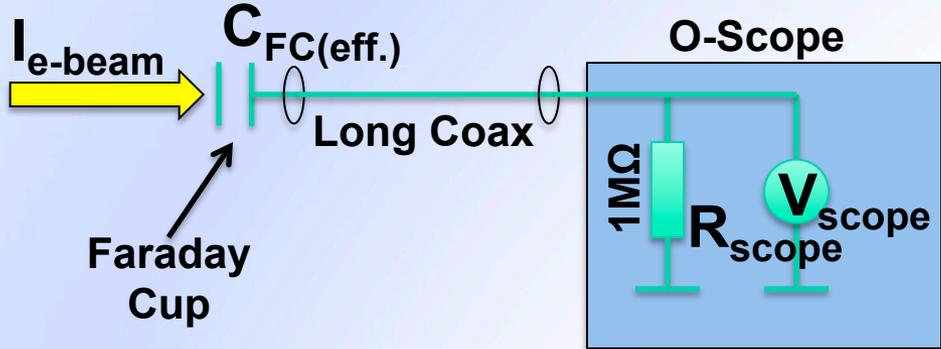
Circuit proposed for bias connection.



Amplifiers & integrators for two faraday cups (plus 6 halo monitors).



# Diag. Beam Line Faraday Cup – DARK CURRENT



- Beam Current into Faraday Cup:
  - Finding effective C:  $[\tau = RC]$ 
    - $C_{FC(eff.)} = 5ms / 1M\Omega = 5nF$
  - We find a Dark Current  $\approx 2\mu A$  during the RF pulse from the voltage measured on the effective capacitance of the Faraday Cup.

Calculated Integral  
21.7mVs

## Dark Current

$$Q = \int I(t)dt = \frac{1}{R} \int V(t)dt$$

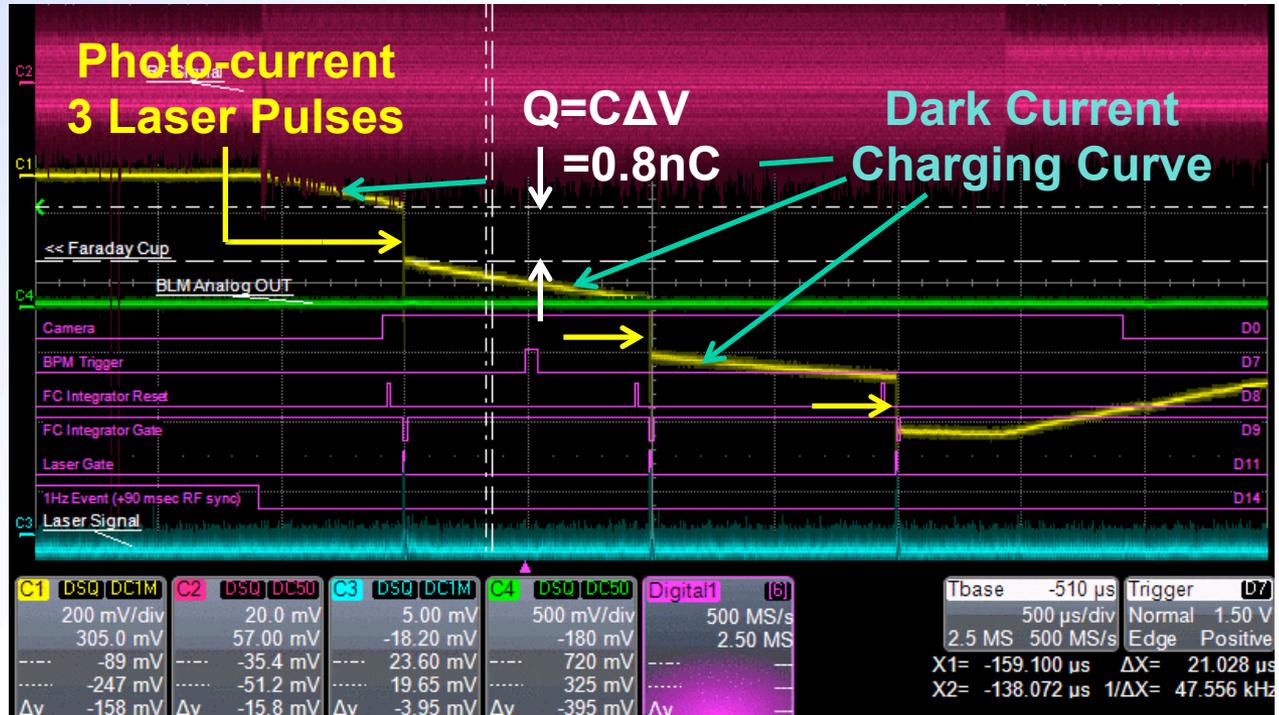
$$\bar{I} = \frac{Q}{T} = \frac{1}{RT} \int V(t)dt$$

$$I = 21.7mVs / 1M\Omega / 10ms = 2.17\mu A$$

# Diag. B/L Faraday Cup – PHOTO-CURRENT



- $\Delta V$  for each beam current pulse gives the charge.
- $Q = C \Delta V$   
 $= (5\text{nF})(158\text{mV})$   
 $= 0.8\text{nC}$
- Superimposed on Dark Current curve



# Integrating Current Transformer



## Bergoz ICT-CF6-60.4-070-05:1-H-UHV-THERMOE

Integrating type, In-flange CT →

For bunches bunches & bunch trains

Bergoz IHR electronics

Noise <1pC beam charge

Calibrated



### Mechanical details:

60.4mm ID

40mm axial length

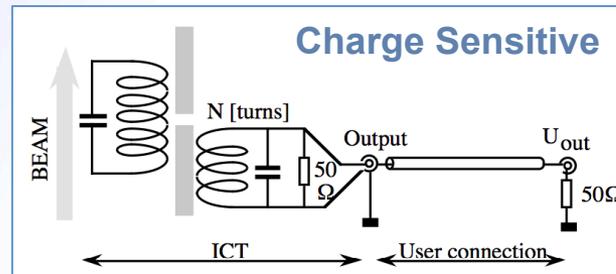
Rad-Hard option

Bakeable to 180C,

plan 48h at 150C

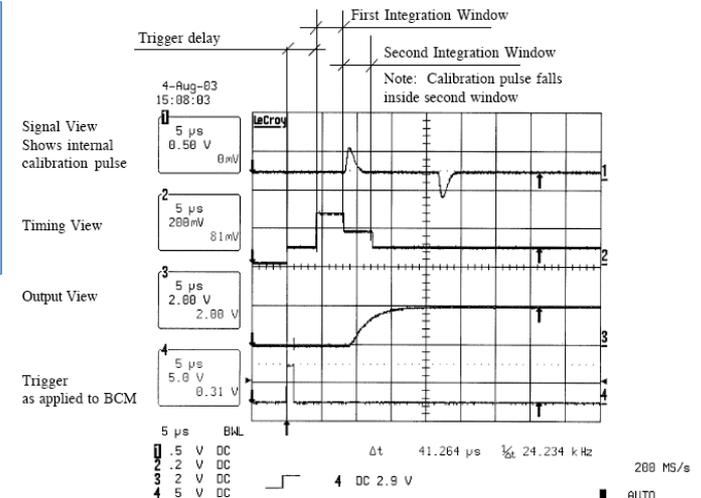
Separate bake-out zone

Internal TC, type-E



### Signal processing timing diagram:

Gate width <0.1us up to >7us



### ERL requirements for bunch charge at 0.1-5nC:

5% accuracy

1% resolution (at 5nC)



Toby Miller

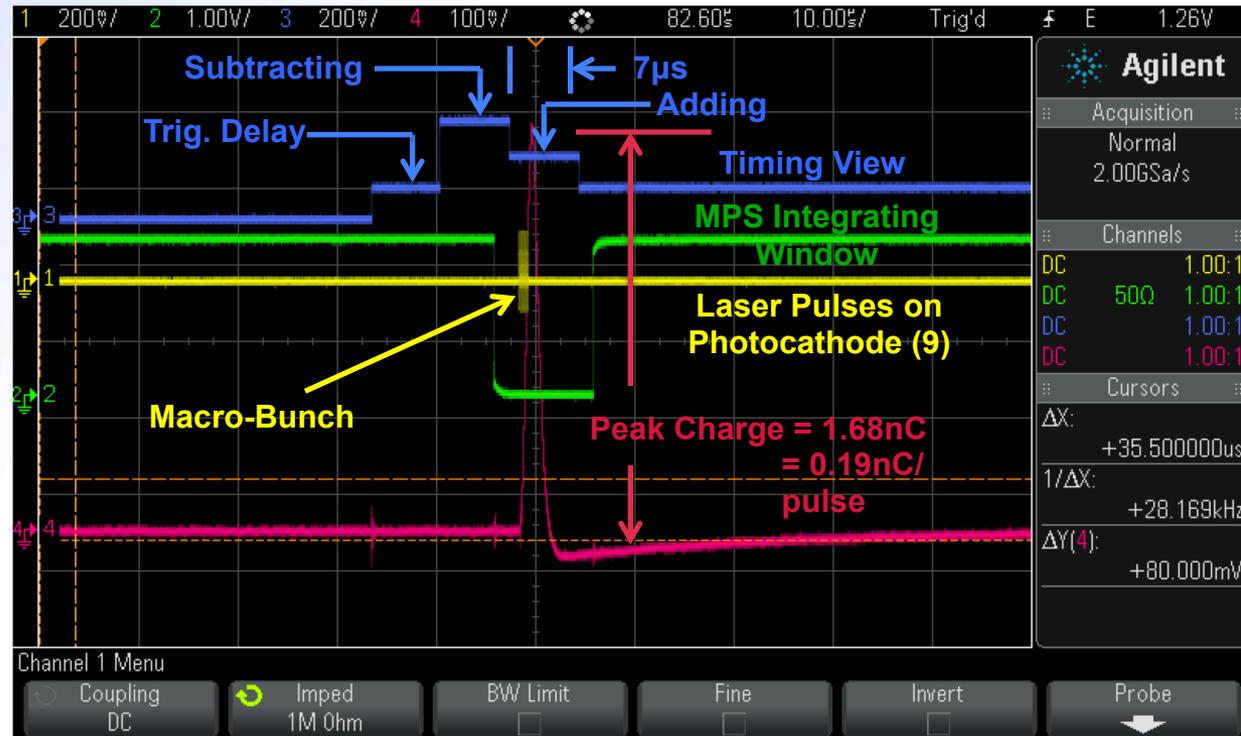


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# Injection – Integrating Current Transformer



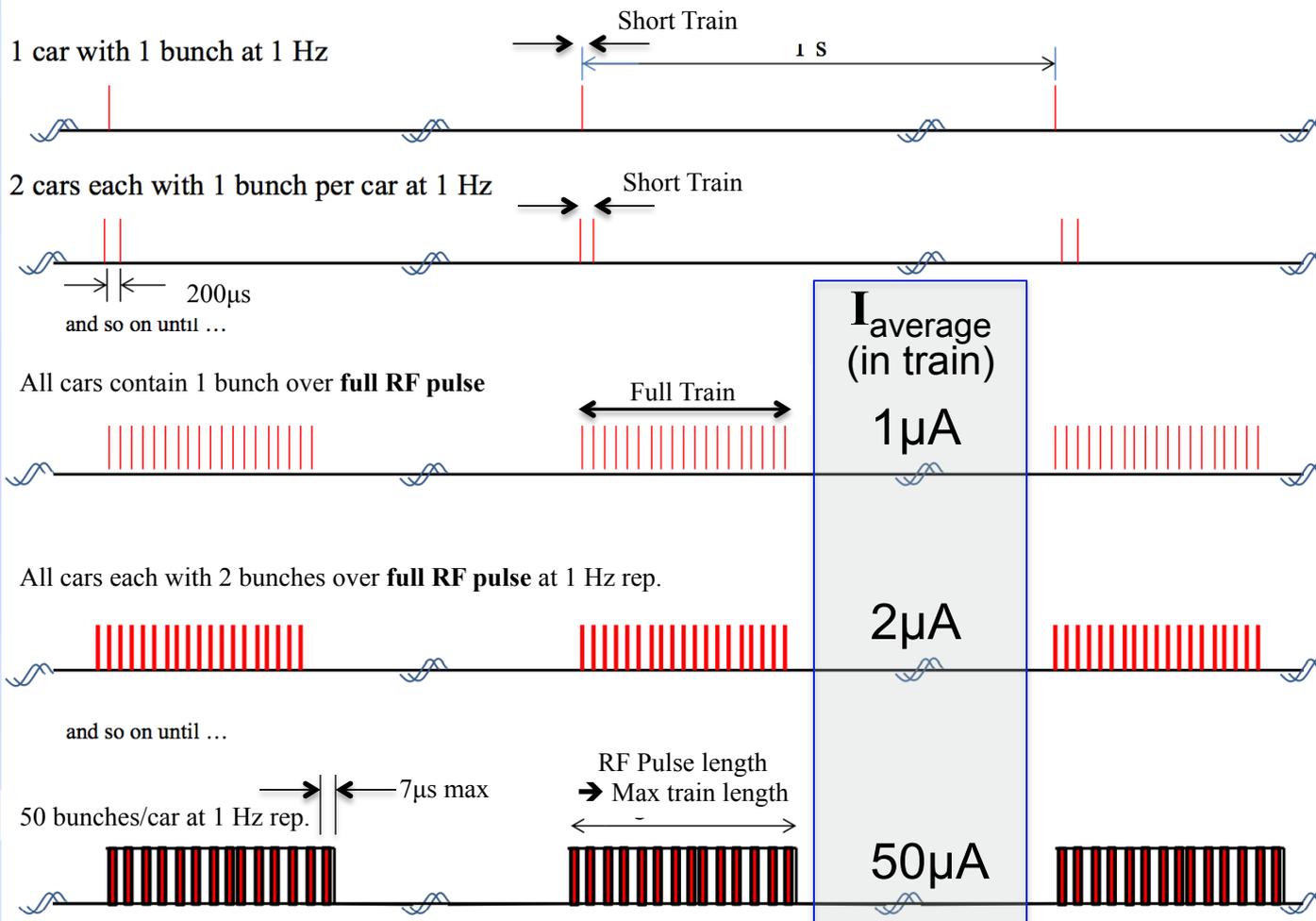
- $7\mu\text{s}$  Integration window
- $1\mu\text{s}$  macro bunch
- 9 pulses with 9.38MHz spacing and 44mW
- 1.68nC total charge
  - 0.19pC per bunch
  - ( $550\text{pC}_{\text{max}}$  demonstrated using 4W laser pulses)





# Bunch Patterns compatible with ICT

Bunch pattern for ramping up the beam current (for fault studies):



- 200pC/bunch
- 5kHz rep.
- 1 – 50 bunches per car

- **ICT**
  - Charge/car
  - 7µs max car length

# Machine Protection – Over Current/Charge

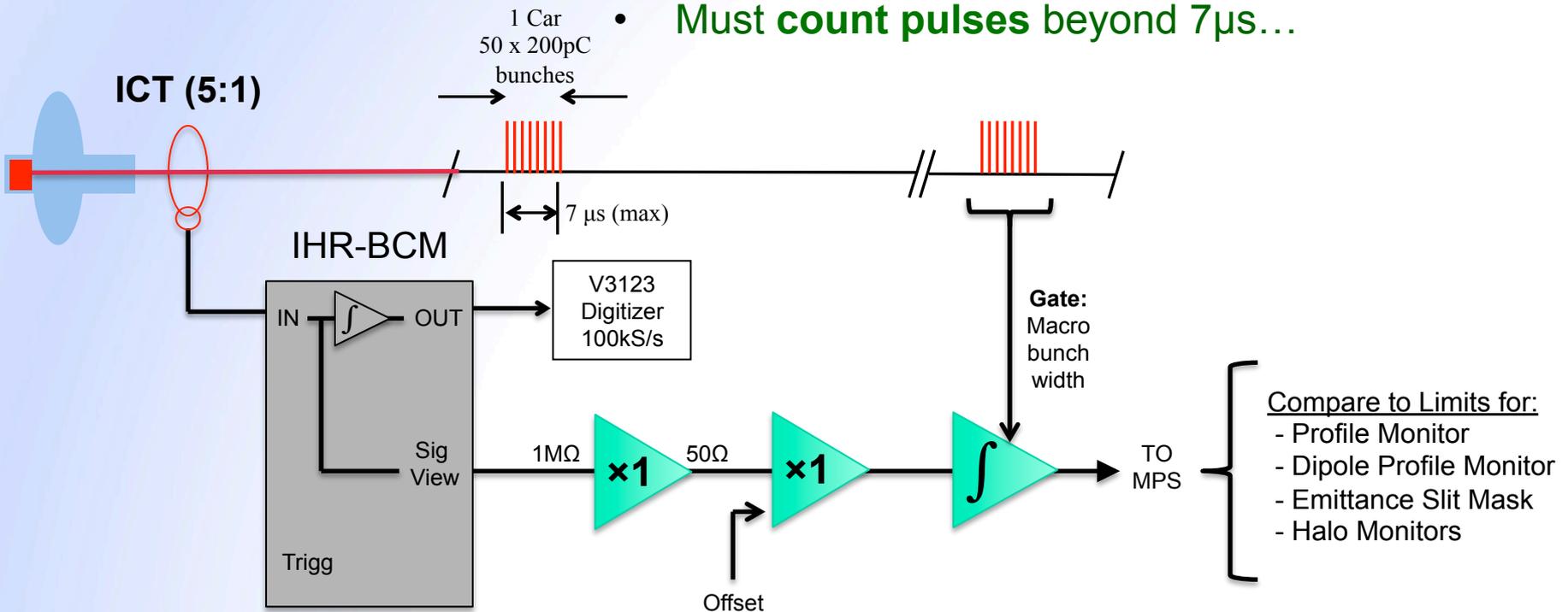


- The ICT is used (under limited pulse structures) to:
  - Limit operational current during commissioning & fault studies
  - Log operational current
  - Limit operational current in “Instrumentation Mode”
    - Specific **charge** thresholds are set during the insertion of each of the following instruments:
      - Profile Monitor
      - Dipole Profile Monitor
      - Emittance Slit Mask
      - Halo Monitors

# ICT interface to MPS



- Dedicated amplifiers & integrators for ICT signal
- MPS compares Charge to limit for inserted device
- Limited to 7 $\mu$ s cars or macrobunches
- **Must count pulses** beyond 7 $\mu$ s...



# Pulse Counting Scheme



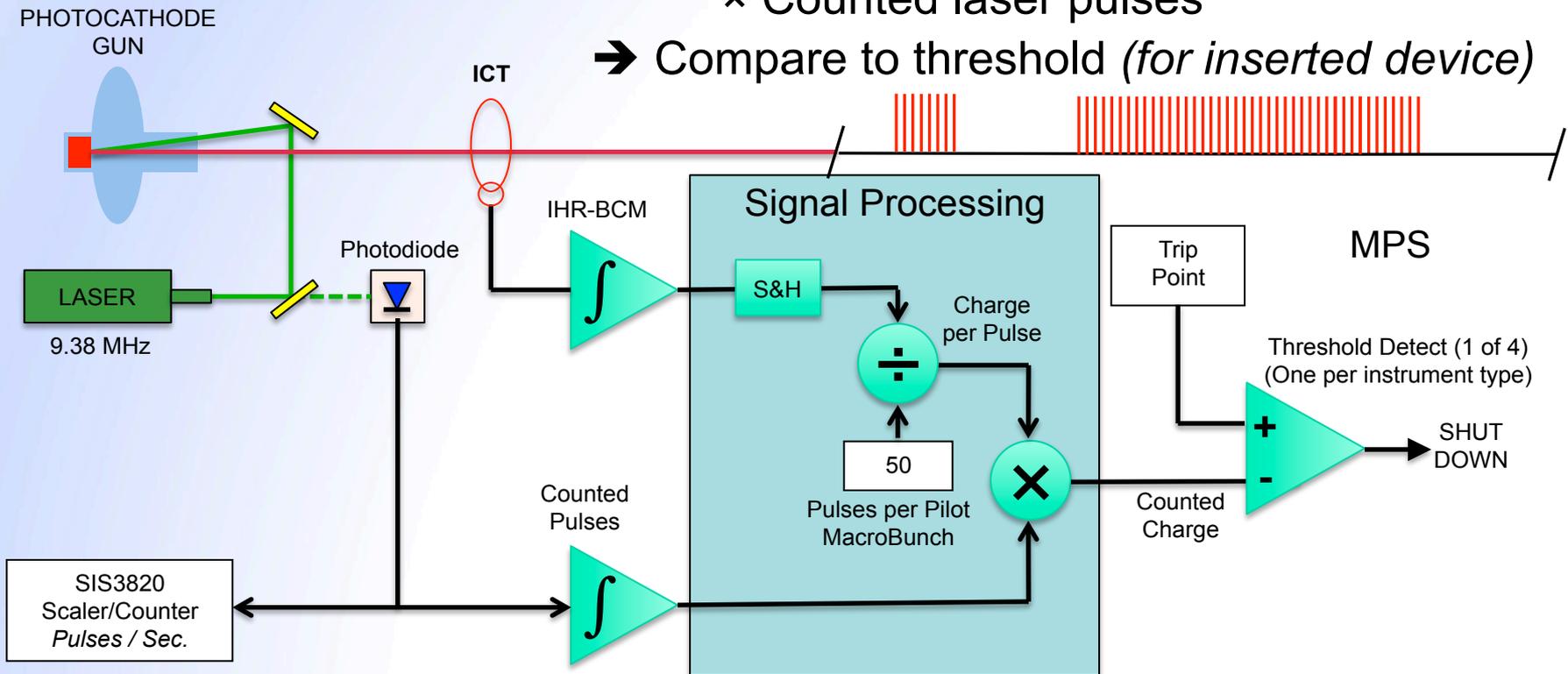
Extending **charge** measurement beyond ICT  $7\mu\text{s}$  window

Pilot macrobunch charge measurement

$\div$  50 pulses in pilot

$\times$  Counted laser pulses

$\rightarrow$  Compare to threshold (*for inserted device*)



# DCCT System



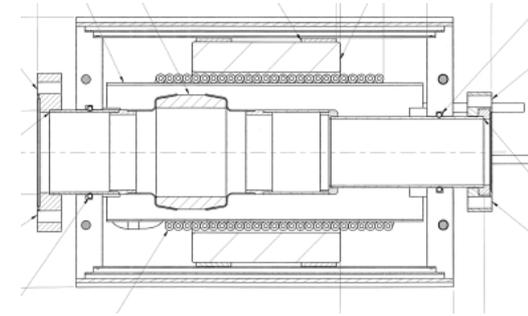
- High precision DC measurement
- DC – 10kHz bandwidth
- ~1uA resolution expected @ 1Hz

## Modes:

- Absolute Gun & Dump currents
- Differential Gun – Dump current for Machine Protection (10uA loss budget)



Bergoz NPCT system



**BNL designed enclosure:**  
Calibration winding  
Water cooling (80C max bake)  
Mu-metal shield

## DIFFERENTIAL SCHEME:

The toroids installed in the injector and dump lines are connected via a current loop that threads both toroids and that is driven by a stable low-noise current source. The current of this source is regulated to minimize the output of the dump toroid. The output of the injector toroid is then the differential current measurement.

## Bergoz model # NPCT-S-115 New Parametric Current Transformer, with options:

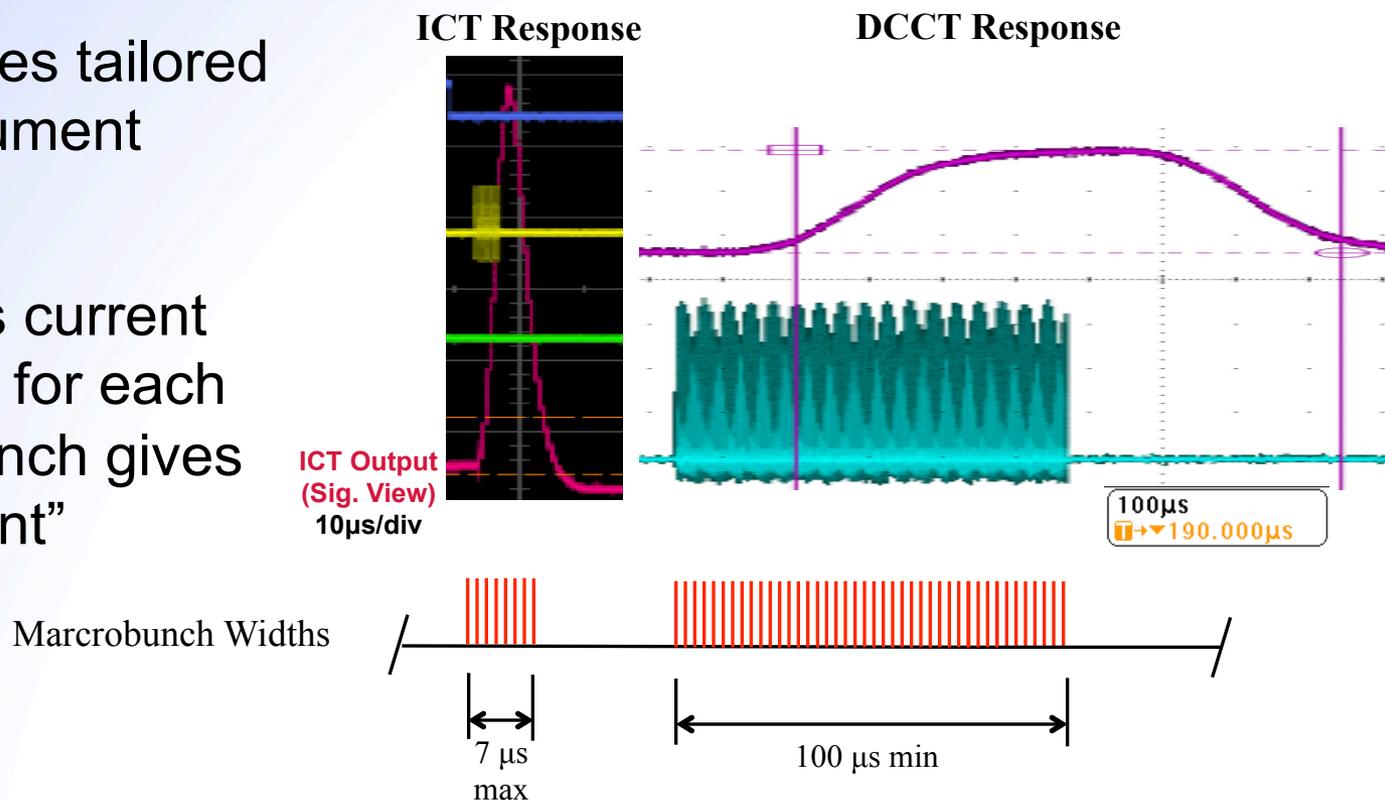
- 115mm ID
- Very high resolution ( $<1\mu\text{A}/(\text{Hz})^{1/2}$ )
- Radiation resistant sensor



# Time response of DCCT vs ICT



- DCCT requires long macrobunches ( $>100\mu\text{s}$ )
- Pulse structures tailored for each instrument (*ICT vs. DCCT*)
- Instantaneous current measurement for each long macrobunch gives a “pulse current”

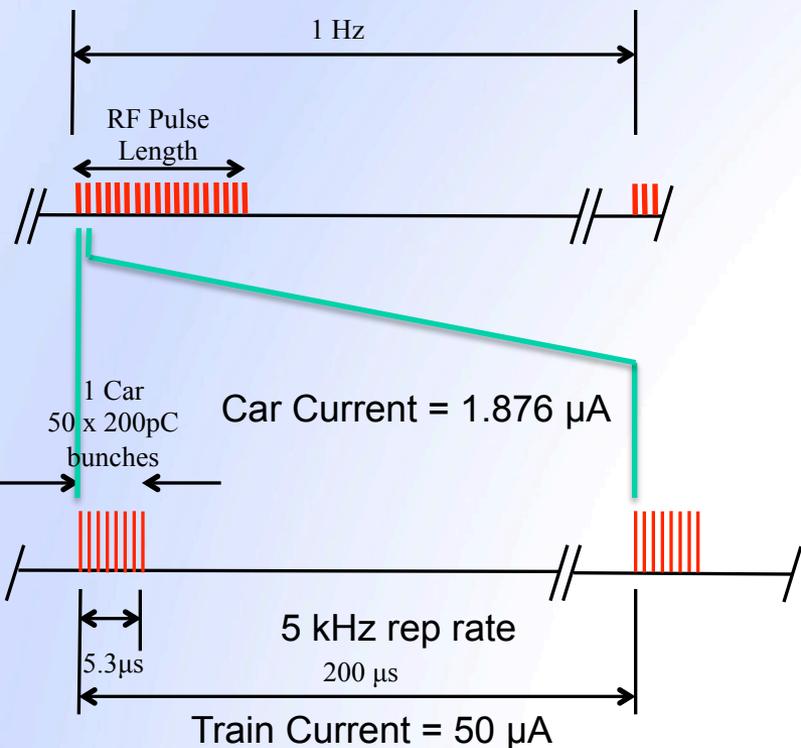




# Bunch Patterns– ICT vs DCCT

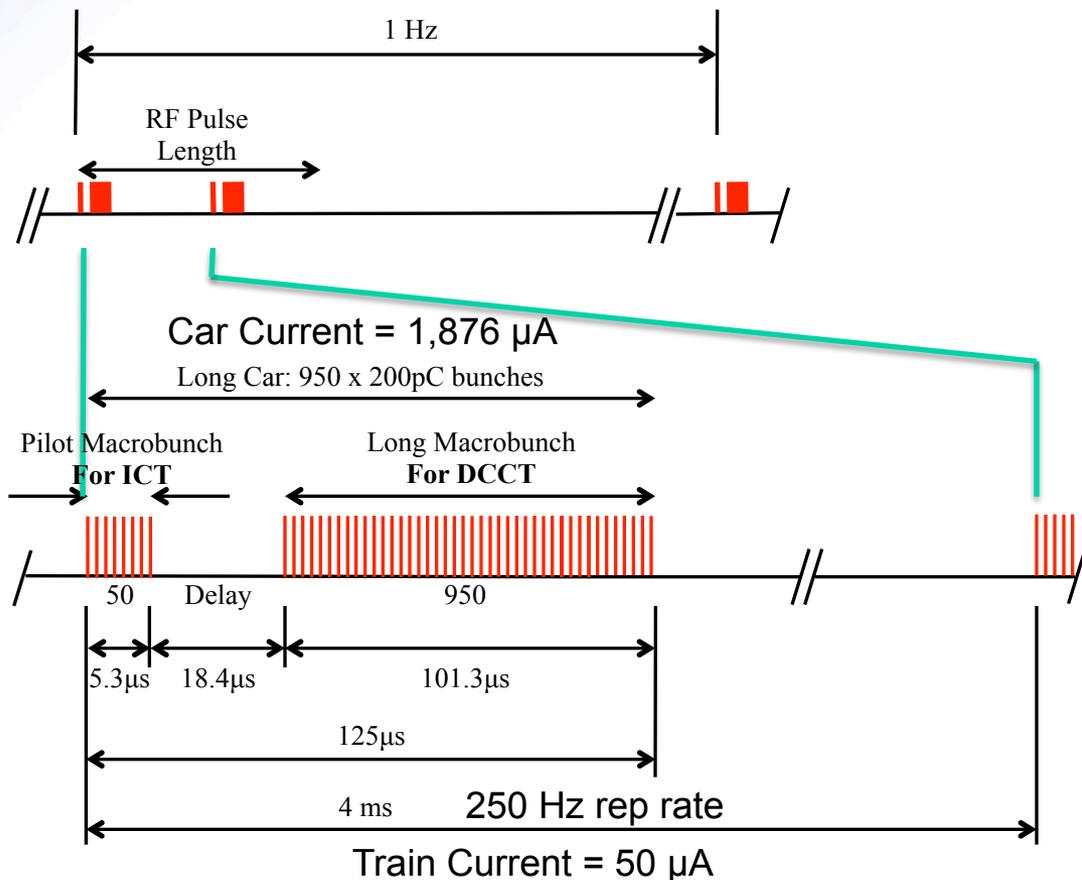
## Pulse Structure for ICT

ICT is gated around the Car



## Pulse Structure for ICT + DCCT

ICT is gated through the Pilot macro pulse  
DCCT is sampled at the end of the Long macro pulse



# Summary



- A Bergoz ICT is used to measure beam charge in short macrobunches
  - Up to  $50\mu\text{A}$  average pulse train currents
- Measurements are confirmed with Faraday Cup
- A pulse counter is planned to be used to extend the measurement range of the ICT
- A Bergoz DCCT is used to measure long macrobunches
- Interlock thresholds are set in the Machine Protection System
- Future plans include the use of differential current measurements using separate DCCTs placed near injection and extraction.

# Acknowledgments

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## BNL C-AD

R&D Energy Recovery Linac Group  
Instrumentation Systems Group  
Controls & Vacuum Group

## Bergoz Instrumentation

Thank you for your attention!